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Substitute for form 1449B/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> Date Submitted: April 28, 2006 <i>(use as many sheets as necessary)</i>			<b>Complete if Known</b> Application Number 10/567,828 Filing Date 02/10/2006 First Named Inventor Tadahiho OHMI Group Art Unit Unassigned Examiner Name Unassigned Attorney Docket Number 039262-0149		
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**U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		Office <sup>3</sup>	Number <sup>4</sup>				

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>6</sup>
	B1	Electronic Journal, 2002, "Electron Projection Lithograph, pp. 62-65, EDS Fair.	
	B2	Nikkei Electronics, "Low Energy E-Beam Proximity Lithography," December 17, 2001, pp. 33, 34.	

Examiner Signature	/Christopher Young/ (03/10/2009)	Date Considered	03/10/2009
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